

FORM PTO-1449 SAMUELS, GAUTHIER & STEVENSON LLP (Rev. 5/92) 225 Franklin Street, Boston, MA 02110 Telephone: (617) 426-9180	Analog. 5683 ATTORNEY DOCKET NO. Brosnihan et al. APPLICANT 08/03/01 FILING DATE	09/921,456 SERIAL NO 2841 2813 GROUP Unknown EXAMINER
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U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
YH	AA	5,216,490	06/01/1993	Greiff et al.			08/03/1990
YH	AB	6,021,675	02/08/2000	Seefeldt et al.			02/28/1997
YH	AC	5,343,064	08/30/1994	Spangler et al.			03/18/1988
	AD						
	AE						
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FOREIGN PATENT DOCUMENTS

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YH	AI	198 47 455 A1	04/27/2000	DE			NO
YH	AJ	0 834 759 A2	08/04/1998	EPO			YES
	AK						
	AL						
	AM						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER INITIAL		
YH	AN	"Embedded Interconnect and Electrical Isolation for High-Aspect-Ratio, SOI Inertial Instruments," Brosnihan et al.; 1997. University of California, Berkeley Sensor & Actuator Center.
	AO	
	AP	

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U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>yk</i>	AA	6,121,552	9/19/00	Brosnihan et al.	—	—	6/13/97
<i>yk</i>	AB	6,044,705	4/4/00	Neukermans et al.	—	—	5/12/97
	AC						
	AD						
	AE						
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	AG						
	AH						

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	AI						
	AJ						
	AK						
	AL						
	AM						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER INITIAL		
<i>yk</i>	AN	"A Raster-Scanning Full-Motion Video Display Using Polysilicon Micromachined Mirrors"; Conant et al., University of California Berkeley & University of California Davis, Engineering II
<i>yk</i>	AO	"Integrated Micromachined Scanning Display Systems"; by Hagelin et al., Department of Electrical and Computer Engineering; University of California Davis & University of California, Berkeley
<i>yk</i>	AP	"Stretched-Film Micromirrors For Improved Optical Flatness"; by Nee et al.; University of California, Berkeley Sensor & Actuator Center

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